

In re Application of: Naruhiko KAJI
 Application No. 10/735,815
 Filed: December 16, 2003
 For: SEMICONDUCTOR DEVICE WITH COPPER WIRING AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

U.S. Patent and Trademark Office
 220 20th Street S. Customer Window, Mail Stop Amendment
 Crystal Plaza Two, Lobby, Room 1B03
 Arlington, VA 22202

Sir:

- ☐ Small entity status is claimed for this application under 37 CFR 1.27.
☐ Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.
☐ Other:
☐ Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

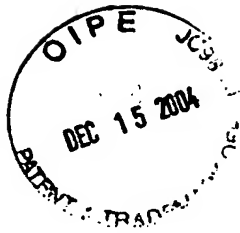
					SMALL ENTITY		OTHER THAN A SMALL ENTITY	
TIME EXTENSION PETITION FEE		none			\$ 0.00		\$ 0.00	
	subtract time extension fee previously paid	none			(\$ 0.00)		(\$ 0.00)	
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADD'L CLAIM FEE	RATE	ADD'L CLAIM FEE
TOTAL		MINUS		=	x 25=	\$	x 50=	\$
INDEPENDENT		MINUS		=	x 100=	\$	x 200=	\$
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM				+ 180=	\$	+ 360=	\$
TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL	\$

- ☒ The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.
☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
☒ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

Jeffrey A. Wyand, Reg. No. 29,458
 LEYDIG, VOIT & MAYER
 700 Thirteenth Street, N.W., Suite 300
 Washington, DC 20005-3960
 (202) 737-6770 (telephone)
 (202) 737-6776 (facsimile)

Date: December 15, 2004
 JAW:tps



PATENT
Attorney Docket No. 402913

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Naruhiko KAJI

Application No. 10/735,815

Art Unit: 2811

Examiner: S. Loke

Filed: December 16, 2003

For: SEMICONDUCTOR DEVICE WITH
COPPER WIRING AND METHOD
FOR MANUFACTURING
SEMICONDUCTOR DEVICE

RESPONSE TO OFFICE ACTION

U.S. Patent and Trademark Office
220 20th Street S. Customer Window, Mail Stop Amendment
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Dear Sir:

In response to the Office Action dated December 1, 2004, please enter the following amendments and consider the following remarks.

In re Appln. of Naruhiko KAJI.
Application No. 10/735,815

TITLE AMENDMENTS

**SEMICONDUCTOR DEVICE WITH COPPER WIRING ~~AND METHOD FOR~~
~~MANUFACTURING SEMICONDUCTOR DEVICE~~**